

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/578,920	FUKUMURA ET	AL.
Examiner	Art Unit	
LOIS ZHENG	1793	

	SEARCHED			
Class	Subclass	Date	Examiner	

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
inventorship search	7/30/2008	LLZ
EAST search	7/30/2008	LLZ